

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application

Inventor (s)	Baer et al.	Docket No.	HSJ9-2003-0032US1
Serial No.	Not yet assigned	Art Unit	Not yet assigned
Filing Date	Not yet assigned	Examiner	Not yet assigned
Title:	METHOD OF FORMING A READ SENSOR USING PHOTORESIST STRUCTURES WITHOUT UNDERCUTS WHICH ARE REMOVED USING CHEMICAL-MECHANICAL POLISHING (CMP) LIFT- OFF PROCESSES		

MAIL STOP PATENT APPLICATION

**Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**

SIR:

INFORMATION DISCLOSURE STATEMENT

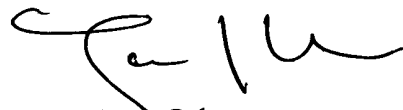
In accordance with 37 CFR 1.97(b), the enclosed Information Disclosure Statement, with attached reference(s), is submitted for consideration in the above-identified application.

A copy of each of the listed documents is enclosed.

NO FEE IS REQUIRED.

The Examiner is respectfully requested to make the listed documents of record in connection with the prosecution of the subject application.

Respectfully,


John J. Oskorep
Reg. # 41,234

Date: 30 Sept 2003

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Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets necessary)</i>				COMPLETE IF KNOWN	
				Application Number	Not Yet Assigned
				Filing Date	Not Yet Assigned
				First Named Inventor	Baer
				Group Art Unit	Not Yet Assigned
				Examiner Name	Not Yet Assigned
SHEET	1	OF	1	Docket Number	HSJ9-2003-0032US1

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code ² (If known)			
		6,353,995	B1	Sasaki et al.	03-12-2002	
		5,087,332		Chen	02-11-2002	
		6,483,664		Kamijima	11-19-2002	
		6,195,229	B1	Shen et al.	02-27-2001	

FOREIGN PATENT DOCUMENTS								
Examiner Initials*	Cite No. ¹	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
		Office ³	Number ⁴	Kind Code ⁵ (If known)				

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T ⁶

Examiner Signature		Date Considered	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two letter-code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard St. 16 if possible. ⁶Applicant is to place a check mark here if English language translation is attached.